

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

09780001AA

Application Number

unknown

Applicant(s)

Masahiko Ishida et al.

Filing Date

March 22, 2006

Group Art Unit

unknown

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
/M.H./		2003-238123	08.27.2003	NEC CORP.	Int. Cl		✓	
/M.H./		2003-017508	17.01.2003	NEC CORP.	Int. Cl		✓	

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

/M.H./		J. Fujita et al. Graphitization of FE-doped amorphous carbon pillars grown by focused-ion-beam-induced chemical-vapor deposition, Journal of Vacuum Science & Technology B, second series, volume 20, number 6, 11/2002; pages 2686-2689
/M.H./		Yoshitazu Homma et al. Growth of suspended carbon nanotube networks on 100-nm-scale silicon pillars; A Applied Physics Letters, volume 81, number 12; 09.16.2002; pages 2261-2263

EXAMINER /Michelle Hou/

DATE CONSIDERED 12/23/2008

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional)	09780001AA	Application Number	0595195 - GAU: 4181
	Applicant(s)			
	NMasahiko Ishida et al.			
	Filing Date	March 22, 2006	Group Art Unit	unknown

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							YES	NO

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

/M.H./		Seizo Kinoshita et al., "Ichi Seigo Seicho Carbon Nanotube ni yoru Shitsuen Coulomb Blockade", The Institute of Electronics, Information and Communication Engineers Gijutsu Kenkyu Hokoku, 29 January, 2002 (29.01.02), Vol.101, No.618, pages 47 to 52

EXAMINER	/Michelle Hou/	DATE CONSIDERED	12/23/2008
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All references considered except those lined through M.H.